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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re application of |) | PROCESS FOR PREPARING |
| |) | NANOSTRUCTURED MATERIALS |
| Sarkas et al. |) | OF CONTROLLED SURFACE |
| |) | CHEMISTRY |
| Application No. |) | |
| |) | Group Art Unit: |
| Filing Date: |) | Examiner: |

Commissioner for Patents
P.O. Box 1450
Mail Stop: Patent Application
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Applicant hereby submits the following Preliminary Amendment to the above-referenced application.

Please amend the Specification as set fourth in the following amendment.